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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES**

Applicant(s): H. Miura, et al.

Application No.: 09/254,939

Filing Date: March 17, 1999

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE
HAVING TRENCH ELEMENT SEPARATION STRUCTURE

Art Unit: 2814

Examiner: Anh D. Mai

**NOTICE OF APPEAL FROM THE PRIMARY
EXAMINER TO THE BOARD OF APPEALS**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 1, 2004

Sir:

In accordance with the provisions of 37 CFR 1.191, Applicants hereby appeal from the final rejection as set forth in the Official Action mailed June 1, 2004, finally rejecting claims 1-6, 9, 10, 12, 13, 15, 18-39 and 41-66.

A Credit Card Payment form in the amount of \$340.00 is enclosed, to cover the Appeal Fee.

Respectfully submitted,

10/04/2004 SDENBDB1 00000050 09254939

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340.00 DP

ANTONELLI, TERRY, STOUT & KRAUS, LLP

William I. Solomon
William I. Solomon
Registration No. 28,565

1300 North Seventeenth Street
Suite 1800
Arlington, VA 22209
Tel.: 703-312-6600
Fax.: 703-312-6666
WIS/sjg